

PATENT APPLICATION

Attorney Docket: 10971608-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Ruby et al

Serial No.:

09/088,964

Filed:

6/2/98

For:

SBAR Structures and Method of Fabrication

of SBAR.FBAR Film Processing Techniques for the Manufacturing of

SBAR/FBAR Filters

Group Art Unit:

2834

Examiner: T. Dougherty

Response to Restriction Requirement

Hon. Commissioner of Patents and Trademarks Washington, D.C. 20231

Sir:

Election

In response to the restriction requirement, Applicant elects Claims 1-6.

I hereby certify that this paper (along with any others attached hereto) is being deposited with the United States Postal Service as first class mail with sufficient postage on the date signed below in an envelope addressed to: Hon. Assistant Commissioner of Patents, Box Amendment, Washington, D.C. 20231.

Respectfully Submitted,

Calvin B. Ward

alb. ldd

Registration No. 30,896

Date signed and mailed: October 6, 1999

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